

INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

June 20, 2025

IGI Report Number

LG717558487

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

SQUARE EMERALD CUT

Measurements

6.38 X 6.33 X 4.06 MM

GRADING RESULTS

Carat Weight

1.55 CARAT

Color Grade

E

Clarity Grade

VS 1

ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT


Symmetry

EXCELLENT

Fluorescence

NONE

Inscription(s)

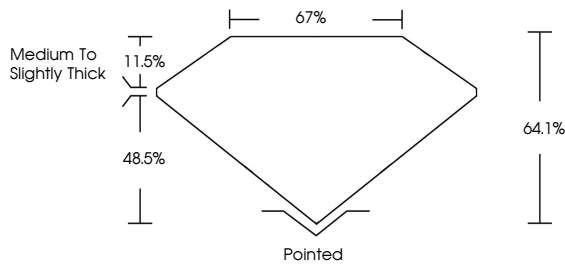
 LG717558487

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

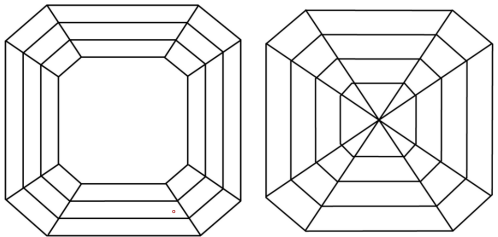
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Report verification at igi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



COLOR

D E F G H I J Faint Very Light Light

CLARITY

IF VS ¹⁻² VS ¹⁻² SI ¹⁻² I ¹⁻³

Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included



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
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Clarity Grade

VS 1

Depth

64.1%

Table

67%

Girdle

Medium to Slightly Thick

Culet

Pointed

Polish

EXCELLENT


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